

Two-Dimensional Field Mapping in MMIC-Substrates by Electro-Optic Sampling Technique

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For the first time two-dimensional substrate internal field mapping of monolithic microwave integrated structures on GaAs by direct electro-optic sampling is presented. Measurements up to 8.5 GHz have been made. It will be shown that this test technique is very useful for internal function and failure analysis of MMIC.

 [Return to main document.](#)